

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Yuji Okawa
Appl. No.	:	10/809,566
Filed	:	March 25, 2004
For	:	WAFER BACK SURFACE TREATING METHOD AND DICING SHEET ADHERING APPARATUS
Examiner	:	Thanhha S Pham
Group Art Unit	:	2813

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated September 19, 2006, Applicants submit the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.